

[illegible]

Scott R. Wilson

2826

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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

[illegible]

EAST 10-092037: Amorphous SiC window coating.wsp:1				10/11/04	
File View Edit Tools Window Help				10/11/04	
D A B C D E F G H I J K L M N O P Q R S T U V W X Y Z				10/11/04	
Index	Search Text	Doc	Time Stamp		
1 1168	(amorphous adj silicon ADJ carbide) WITH (coating or layer)	USPAT; US-PGPUB; EPO; 2004/08/11 15:32 JPO; DERWENT; IBM_TDB			
2 1256	257/76,77.ccls. 438/105,931.ccls.	USPAT; US-PGPUB; EPO; 2002/10/10 14:56 JPO; DERWENT; IBM_TDB			
3 2	(amorphous adj silicon ADJ carbide) and (electromagnetic adj interference)	USPAT; US-PGPUB; EPO; 2002/10/10 14:57 JPO; DERWENT; IBM_TDB			
4 72	(257/76,77.ccls. 438/105,931.ccls.) and (amorphous adj silicon ADJ carbide)	USPAT; US-PGPUB; EPO; 2004/08/12 11:55 JPO; DERWENT; IBM_TDB			
5 13	((257/76,77.ccls. 438/105,931.ccls.) and (amorphous adj silicon ADJ carbide)) and (transparent with light)	USPAT; US-PGPUB; EPO; 2002/12/12 13:16 JPO; DERWENT; IBM_TDB			
6 1	((257/76,77.ccls. 438/105,931.ccls.) and (amorphous adj silicon ADJ carbide)) and (electromagnetic with interference)	USPAT; US-PGPUB; EPO; 2002/10/10 16:57 JPO; DERWENT; IBM_TDB			
7 1	((257/76,77.ccls. 438/105,931.ccls.) and (amorphous adj silicon ADJ carbide)) and (emi)	USPAT; US-PGPUB; EPO; 2002/10/10 16:56 JPO; DERWENT; IBM_TDB			
8 2	(amorphous adj silicon ADJ carbide) and (emi)	USPAT; US-PGPUB; EPO; 2002/10/21 13:16 JPO; DERWENT; IBM_TDB			
9 3	(amorphous adj silicon ADJ carbide) and (electromagnetic with interference)	USPAT; US-PGPUB; EPO; 2002/10/11 14:38 JPO; DERWENT; IBM_TDB			
10 2	6031250 .pn.	USPAT; US-PGPUB; EPO; 2002/10/10 17:08 JPO; DERWENT; IBM_TDB			
11 2	6268229 .pn.	USPAT; US-PGPUB; EPO; 2002/10/10 17:09 JPO; DERWENT; IBM_TDB			
12 77	((electromagnetic adj interference) with shield) same film	USPAT; US-PGPUB; EPO; 2002/12/12 13:16 JPO; DERWENT; IBM_TDB			
13 13	((electromagnetic adj interference) with shield) same (thin adj film)	USPAT; US-PGPUB; EPO; 2002/12/12 13:16 JPO; DERWENT; IBM_TDB			
14 6	("5270488" "5153379" "5166772").pn.	USPAT; US-PGPUB; EPO; 2002/10/11 14:07 JPO; DERWENT; IBM_TDB			
15 106	(amorphous adj silicon ADJ carbide) same (conductivity or resistivity)	USPAT; US-PGPUB; EPO; 2002/10/11 14:50 JPO; DERWENT; IBM_TDB			
16 104	(amorphous adj silicon ADJ carbide) with (conductivity or resistivity)	USPAT; US-PGPUB; EPO; 2002/12/12 13:16 JPO; DERWENT; IBM_TDB			
17 9	(amorphous adj silicon ADJ carbide) with (conductivity or resistivity) and omega	USPAT; US-PGPUB; EPO; 2002/10/11 15:08 JPO; DERWENT; IBM_TDB			
18 9	(amorphous adj silicon ADJ carbide) with (conductivity or resistivity) and "omega"	USPAT; US-PGPUB; EPO; 2002/10/11 15:09 JPO; DERWENT; IBM_TDB			
19					
J REC Update 10/11/04					
Ready				10/11/04	

updated EAST 8/11/04

1/11/11 Details 1/11/11

☒ 1st ☐ Delays ☐ 5th ☐ 10th ☐ 15th ☐ 20th ☐ 25th ☐ 30th ☐ 35th ☐ 40th ☐ 45th ☐ 50th ☐ 55th ☐ 60th ☐ 65th ☐ 70th ☐ 75th ☐ 80th ☐ 85th ☐ 90th ☐ 95th ☐ 100th

✓ 1st () Delate 2nd 5/7/8